



Docket No.: 970.1011

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Toshiaki KAKEMURA et al.

Serial No. 10/529,362

Group Art Unit: 1715

Confirmation No. 4778

Filed: March 28, 2005

Examiner: BURKHART, ELIZABETH A

For: THIN FILM FORMING METHOD, THIN FILM FORMING DEVICE, AND THIN FILM FORMING PROCESS MONITORING METHOD

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the non-final Office Action mailed April 5, 2010, and having a period for response set to expire on July 5, 2010.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.